

## FISCHERSCOPE® X-RAY XDV®-μ LD

X-Ray Fluorescence Measuring Instrument with a Polycapillary X-Ray Optics for Measurements on Very Small Components and Structures



# FISCHERSCOPE® X-RAY XDV®-μ LD

## Description

The FISCHERSCOPE X-RAY XDV-μ LD (Long Distance) is a universally applicable energy dispersive x-ray fluorescence measuring instrument. It is particularly well suited for non-destructive analyses and measurements of coating thicknesses on very small components and structures, even with complex coating systems.

Typical fields of application:

- Measurements on very small components and structures such as printed circuit boards, contacts or lead frames
- Analysis of very thin coatings, e.g., gold coatings of  $\leq 0.1 \mu\text{m}$  (0.004 mils)
- Measurements of functional coatings in the electronics and semiconductor industries
- Determination of complex multi-coating systems
- Automated measurements, e.g., in quality control

To create ideal excitation conditions for every measurement, the instrument features electrically changeable primary filters. The modern silicon drift detector achieves high accuracy and good detection sensitivity.

Due to the innovative polycapillary x-ray optics, the instrument measures using an extremely small measurement spot yet with a very high excitation intensity. The polycapillary x-ray optics is dimensioned so that it enables for a longer measuring distance. This allows for measurements on parts with complex geometries, e.g. on assembled printed circuit boards.

Outstanding accuracy and long-term stability are characteristics of all FISCHERSCOPE X-RAY systems. The necessity of recalibration is considerably reduced, saving time and effort.

The fundamental parameter method by FISCHER allows for the analysis of solid specimens and coating systems without calibration.

For measurements on large printed circuit boards, the instrument can be equipped with a larger sample stage.

## Design

The FISCHERSCOPE X-RAY XDV-μ LD is designed as a user-friendly bench-top instrument. It is equipped with a high-precision, programmable XY-stage and an electrically driven Z-axis. A gap in the housing allows for measurements on large flat specimens, which do not fit in the measuring chamber, e.g. large printed circuit boards. The sample stage moves into the loading position automatically, when the protective hood is opened.

A laser pointer serves as a positioning aid and supports the quick alignment of the sample to be measured. A high-resolution color video camera simplifies the precise determination of the measurement spot.

The entire operation and evaluation of measurements as well as the clear presentation of measurement data is performed on a PC, using the powerful and user-friendly WinFTM® software.

The FISCHERSCOPE X-RAY XDV-μ LD fulfills DIN ISO 3497 and ASTM B 568.

## General Specification

Intended use	Energy dispersive x-ray fluorescence measuring instrument (EDXRF) to measure thin coatings and coating systems on very small flat structures
Design	Bench-top unit with housing with a slot on the side X/Y- and Z-axis electrically driven and programmable Motor-driven changeable filters
Measuring direction	Top down

### X-Ray Source

X-ray tube	Standard: Micro focus tube with tungsten target and beryllium window Optional: Micro focus tube with molybdenum target and beryllium window
High voltage	Three steps: 10 kV, 30 kV, 50 kV
Primary filter	4x changeable: Ni 10 µm (0.4 mils); free; Al 1000 µm (40 mils); Al 500 µm (20 mils)
X-ray optics	Polycapillary
Measurement spot, fwhm at Mo-K <sub>α</sub>	approx. Ø 60 µm (2.4 mils)

### X-Ray Detection

X-ray detector	Peltier-cooled silicon-drift-detector (SDD), effective area 20 mm <sup>2</sup> (0.03 in <sup>2</sup> )
Effective detector area	optionally 20 mm <sup>2</sup> or (0.03 in <sup>2</sup> ) or 50 mm <sup>2</sup> or (0.08 in <sup>2</sup> ), with the SDD 50 mm <sup>2</sup> you can achieve even higher count rates, thus reducing the measuring time and/or improving repeatability
Element range	Sulphur S (16) to Uranium U (92) – up to 24 elements simultaneously
Measuring distance between specimen surface to lower edge of measuring head	fixed, appr. 14 mm (0.6 in), min. 12 mm (0.5 in)

### Sample Alignment

Video microscope	High-resolution CCD color camera for optical monitoring of the measurement location, manual focusing and auto-focus, crosshairs with a calibrated scale (ruler) and spot-indicator, adjustable LED illumination, laser pointer (class 1) to support accurate specimen placement
Zoom factor	Digital 1x, 2x, 3x, 4x

### Sample Stages

	Standard	Option Supporting Plate PCB
Design	Fast, programmable XY-stage with pop out function	Fast, programmable XY-stage with pop-out function and large placement area for measurements on PCBs
Usable sample placement area	Width x depth [mm]: 370 x 320, [in]: 14.6 x 12.6	Width x depth [mm]: 620 x 530, [in]: 24.4 x 20.9
Usable maximum travel		X/Y-axis: 250 x 220 mm (9.8 x 8.7 in) Z-axis: 140 mm (5.5 in)
Max. sample weight	5 kg (11 lb), with reduced approach travel precision 20 kg (44 lb)	
Max. sample height	135 mm	
Max. travel speed X/Y	60 mm/s (2.4 in/s)	
Repeatability precision X/Y	direction-independent: ≤ 5 µm (0.2 mils) max., ≤ 2 µm (0.08 mils) typ.	

### Electrical data

Power source	AC 100 – 240 V ±10 % / 50 – 60 Hz max. 180 VA, without evaluation PC
Protection class	IP40

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## Dimensions

External dimensions	Width x depth x height [mm]: 660 x 835 x 720, [in]: 26 x 33 x 28.3
Weight	Approx. 135 kg (298 lb)
Interior dimensions measurement chamber	Width x depth x height [mm]: 580 x 560 x 145, [in]: 22.8 x 22 x 5.7

## Environmental conditions

Operating temperature	10 °C – 35 °C / 50 °F – 95 °F
Storage/Transport temperature	0 °C – 50 °C / 32 °F – 122 °F
Relative humidity	≤ 95 %

## Evaluation unit

Computer	Windows® PC
Software	Standard: Fischer WinFTM® BASIC including PDM, Optional: Fischer WinFTM® SUPER

## Standards

CE approval	EN 61010, EN 61326
X-Ray standards	DIN ISO 3497 and ASTM B 568
Approval	Individual acceptance inspection as a fully protected instrument according to German radiation protection law

## Order

To create an optimal configuration for your needs, please contact your local Fischer representative.

FISCHERSCOPE® X-RAY XDV®-μ LD	<ul style="list-style-type: none"><li>▪ Select the X-ray tube</li><li>▪ Select the detector</li></ul>
Options	<ul style="list-style-type: none"><li>▪ Stone plate with damping feet, for vibration damping, if a table is available, including stone plate and eight damping feet (1001671)</li><li>▪ Vibration damped table, for vibration damping, including table, stone plate and eight damping feet (1001672)</li><li>▪ Supporting Plate PCB (1002328)</li><li>▪ Software Fischer WinFTM® SUPER</li></ul>

Special XDV-μ LD product modification and technical consultation on request

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